

Refine Search

Search Results -

Terms	Documents
(etch\$ same sonic\$ same silicon same select\$) and semiconductor	8

Database:

US Pre-Grant Publication Full-Text Database

 US Patents Full-Text Database
 US OCR Full-Text Database
 EPO Abstracts Database
 JPO Abstracts Database
 Derwent World Patents Index
 IBM Technical Disclosure Bulletins

Search:

L20

Search History

 DATE: Tuesday, February 28, 2006 [Printable Copy](#) [Create Case](#)

Set Name Query

side by side

Hit Count Set Name

result set

DB=PGPB; PLUR=YES; OP=ADJ
L20 (etch\$ same sonic\$ same silicon same select\$) and semiconductor

 8 L20
DB=USPT; PLUR=YES; OP=ADJ
L19 (etch\$ same sonic\$ same silicon same select\$) and semiconductor

 4 L19
L18 etch\$ same sonic\$ same silicon and semiconductor

 46 L18
L17 etch\$ same sonic\$ same silicon

 57 L17
DB=JPAB; PLUR=YES; OP=ADJ
L16 etch\$ near5 sonication

 0 L16
DB=EPAB; PLUR=YES; OP=ADJ
L15 etch\$ near5 sonication

 0 L15
DB=TDBD; PLUR=YES; OP=ADJ
L14 etch\$ near5 sonication

 0 L14
L13 L12

 0 L13
DB=DWPI; PLUR=YES; OP=ADJ
L12 etch\$ near5 sonication

 1 L12
DB=USPT; PLUR=YES; OP=ADJ
L11 etch\$ near5 sonication

 16 L11
L10 6770568.pn. and sonication

 1 L10

<u>L9</u>	6322954.pn. and sonication	0	<u>L9</u>
<u>L8</u>	5821175.pn. and sonication	0	<u>L8</u>
<u>L7</u>	5057184.pn. and sonication	0	<u>L7</u>
<u>L6</u>	4681657.pn. and sonication	0	<u>L6</u>
<i>DB=PGPB; PLUR=YES; OP=ADJ</i>			
<u>L5</u>	etch\$ same sonication same silicon	31	<u>L5</u>
<i>DB=USPT; PLUR=YES; OP=ADJ</i>			
<u>L4</u>	etch\$ same sonication and silicon	59	<u>L4</u>
<i>DB=DWPI; PLUR=YES; OP=ADJ</i>			
<u>L3</u>	etch\$ same sonication and silicon	1	<u>L3</u>
<i>DB=USPT; PLUR=YES; OP=ADJ</i>			
<u>L2</u>	etch\$ same silicon same sonication	14	<u>L2</u>
<u>L1</u>	etch\$ same silicon same socication	0	<u>L1</u>

END OF SEARCH HISTORY

Refine Search

Search Results -

Terms	Documents
etch\$ near7 sonic and (semiconductor or silicon or substrate)	60

Database:

US Pre-Grant Publication Full-Text Database
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Search:

L3

Search History

 DATE: Tuesday, February 28, 2006 [Printable Copy](#) [Create Case](#)

Set Name Query

side by side

Hit Count Set Name

result set

DB=USPT; PLUR=YES; OP=ADJ

L3 etch\$ near7 sonic and (semiconductor or silicon or substrate)

60

L3

DB=DWPI; PLUR=YES; OP=ADJ

L2 etch near5 sonic and (semiconductor or silicon or substrate)

10

L2

DB=USPT; PLUR=YES; OP=ADJ

L1 etch near5 sonic and (semiconductor or silicon or substrate)

10

L1

END OF SEARCH HISTORY